

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/511,283	GIRBIG, PAUL	
Examiner		Art Unit		Page 1 of 2
JONATHAN G. STERRETT		3623		

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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